

AMENDMENTS TO THE SPECIFICATION

Kindly replace paragraph [0047] with the following amended paragraph:

[0047] An additional spacer substrate 136, which may include additional spacing structures 138, separates the lens 132 from an isolator stack 140. The spacing structures 138 are used when a passive optical element is on one or more opposing surfaces in the stack and the surfaces would otherwise ~~by flush at~~ contact the passive optical element. The spacing structures may be integral with the surface or may be provided on the surface. Alternatively, these spacing structures may be on the sealer substrate 130. The electrical connection of the optoelectronic device 116 is realized using the ledge 115, as discussed in connection with FIG. 9.

Kindly replace paragraph [0048] with the following amended paragraph:

[0048] The isolator stack 140 includes a first polarizer 142, a Faraday rotator 144 and a second polarizer 146. The magnet 170, which may be a ring magnet, surrounds the isolator stack 140 when the optical chassis 100 is inserted as shown in FIG. 12A, thereby completing the isolator. If the Faraday rotator 144 is a latching type, then the ~~separated~~ separate magnet 170 is not needed.